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Date: November 18, 2004Time: 3:52 PM7 Total Number of Pages (Including Cover Sheet)Office Fax Number
Stamford, CT 203.323.6513**I. Please Deliver To:**

Name	Firm	Fax Number
CHUNG, DAVID Y.	U.S. Patent & Trademark Office	703-872-9306

Attention: Examiner CHUNG, DAVID Y.
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
Group Art Unit No.: 2871**Comments:**

Examiner SAIN:

Please find attached hereto an Amendment Response relating to:

Patent Application Serial No.: 09/745,914, filed December 22, 2000.

David L. Barnes
Reg. No.: 47,407**II. From:**Name DAVID L. BARNESAtt.
Reg. # 47,407

Operator Name _____

Operator Number 203.323.6513**III. Confirmation:**Telephone No. 203-326-2973Name (or Title) DAVID L. BARNESMatter Number U.S. PAT. APP. NO. 09/745,914

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Date: November 18, 2004


David L. Barnes

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Antonius Henricus Maria Raaijmakers et al.
Serial No.: 09/745,914
For: ELECTRO-OPTICAL DEVICE HAVING AN ITO LAYER, A SiN LAYER AND AN INTERMEDIATE SILICON OXIDE LAYER
Filed: December 22, 2000
Examiner: Chung, David Y.
Group Art Unit: 2871

Attorney Docket No.: PHN 17,819

Mail Stop: AF Amendment
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

AMENDMENT and RESPONSE

Dear Sir:

In response to the Office Action dated September 8, 2004, please amend the above-noted application as follows:

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.